PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Ui Sik KIM

Serial No.: New Application Group Art Unit: Not Yet Assigned

Filed: December 10, 2003 Examiner: Not Yet Assigned

Title: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

## INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 10, 2003

Sir:

As a means of complying with the duty of disclosure under 37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicant(s), through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached.

In accordance with 37 CFR §1.97(b)(1) or (2), this Information Disclosure Statement is being filed either within three months of the filing date of the above-identified application, or within three months of the date of entry into the national stage of the above-identified application as set forth in 37 CFR §1.491. Accordingly, no fee is required.

Respectfully submitted,

JACOBSON HOLMAN, PLLC

Ву:				 
	Yoon	s.	Ham	

Yoon S. Ham Registration No. 45,307

400 Seventh Street, N.W. Washington, DC 20004 (202) 638-6666

Atty. Dkt. No.: P69373US0 YSH:kyc ها دي الاستان

## JACOBSON HOLMAN, PLLC

400 SEVENTH STREET, N.W. WASHINGTON, D.C. 20004-2201

## LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO.: SERIAL NO.:			New Application			GROUP ART UNIT: Not Yet Assigned FILING DATE: December 10, 2003			
APPLICA	ANT(S):	:	Ui Sik KIM			TODAY'S DATE: December 10, 2003			
*****	*****	* * * * *	*****	*****	*****	******	*****	*****	*****
				U.S.	PATENT DOCU	MENTS			
		UMENT MBER	DATE	NAME	1	INT'L CLASS		FILING DATE (If Appropriate)	
	AA	6,44	<u>4,578</u>	9/03/02	Cabral, Jr.	<u>, et al</u> .	<u>H01L</u>	21/44	2/21/01
	AB	2002	/115262	8/22/02	Cabral, Jr.	<u>, et a</u> l.	<u>H01L</u>	21/76	2/21/01
	AC	2003	<u>/57553</u>	3/27/03	DelaRosa,	et al.	H01L	21/4763	4/03/00
*****	****	****	*****	*****	· * * * * * * * * * * * * * * * * * * *	*****	* * * * * *	****	****
				FOREIGN	I PATENT DO	CUMENTS			
			UMENT MBER	DATE	COUNT	COUNTRY		SUB- S <u>CLASS</u>	TRANSLATION (YES) (NO)
<del></del>	AD		<del></del>						
	AE					<del></del>	<del>-</del>		
*****	****	* * * * *	* * * * * * * *	*****	*****	****	*****	*****	*****
	OTHER	ART	(Includi	ng Author	r, Title, Da	ate, Per	tinent	Pages, 1	Etc.)
	AF								
	A.C.								
	AG								
EXAMINER					DATE CO	ONSIDERED	<del></del>		

<sup>\*</sup> EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).